



MAIL STOP AF
Atty. Docket No. 8020-1002-1
PATENT

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IN THE U.S. PATENT AND TRADEMARK OFFICE

In re application of

Yoshiaki HISAMUNE et al.

Conf. No. 3150

Serial No. 10/083,611✓

Group 2812

Filed February 27, 2002

Examiner Richard A. Booth

METHOD OF MANUFACTURING
SEMICONDUCTOR DEVICE, NONVOLATILE
SEMICONDUCTOR MEMORY DEVICE AND
METHOD OF MANUFACTURING THE SAME

AMENDMENT AFTER FINAL REJECTION

Commissioner for Patents
PO Box 1450
Alexandria, Virginia 22313-1450

August 6, 2003

Sir:

In response to the final Official Action mailed May 8, 2003, please amend the above-identified application as follows:

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Amendments to the Drawings begin on page 8 of this paper and include an attached replacement sheet.

Remarks begin on page 9 of this paper.

An **Appendix** is attached following the signature page of this paper.